

<b>Notice of References Cited</b>	Application/Control No. 10/659,431	Applicant(s)/Patent Under Reexamination PARK, GEUN-YONG	
	Examiner Hai C. Pham	Art Unit 2861	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0100547	05-2004	Hattori, Tomoaki	347/115
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